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Application/C ntr I No.	Applicant(s)/Patent under R examinati n	,	
10/521,683	SCHMIDT ET AL.		
Examiner	Art Unit		
Hai H. Huynh	3747		

SEARCHED			
Class	Subclass	Date	Examiner
123	598	5/23/2006	ннн
123	599	5/23/2006	ннн
123	601	5/23/2006	ннн
123	605-606	5/23/2006	ннн
123	608	5/23/2006	ннн
123	143B	5/23/2006	ннн
123	634	5/23/2006	ннн
333	246-248	5/23/2006	ннн
333	99PL	5/23/2006	ннн
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INTERFERENCE SEARCHED				
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